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High-sensitivity hybrid MoSe₂/AgInGaS quantum dot heterojunction photodetector†

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Zero-dimensional (0D)–two-dimensional (2D) hybrid photodetectors have received widespread attention due to their outstanding photoelectric performances. However, these devices with high performances mainly employ quantum dots that contain toxic elements as sensitizing layers, which restricts their practical applications. In this work, we used eco-friendly AgInGaS quantum dots (AIGS-QDs) as a highly light-absorbing layer and molybdenum diselenide (MoSe₂) as a charge transfer layer to construct a 0D–2D hybrid photodetector. Notably, we observed that MoSe₂ strongly quenches the photoluminescence (PL) of AIGS-QDs and decreases the decay time of PL in the MoSe₂/AIGS-QDs heterojunction. The MoSe₂/AIGS-QDs hybrid photodetector demonstrates a responsivity of 14.3 A W⁻¹ and a high detectivity of 6.4 × 10¹¹ Jones. Moreover, the detectivity of the hybrid phototransistor is significantly enhanced by more than three times compared with that of the MoSe₂ photodetector. Our work suggests that 0D–2D hybrid photodetectors with multiplex I–III–VI QDs provide promising potential for future high-sensitivity photodetectors.

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1. Introduction

In recent decades, graphene, being a representative 2D material, has gained significant attention due to its exceptionally high carrier mobility (2 × 10⁵ cm² V⁻¹ s⁻¹), wide range of optical absorption coefficients (7 × 10⁵ cm⁻¹), and excellent photoelectric conversion efficiency.^{1–3} These properties make it highly attractive for the development of high-speed and broadband photodetectors.^{4,5} Nonetheless, the semi-metallic property with low light absorptivity of only 2.3% results in the large dark current and low photoelectric response of graphene-based devices.⁶ This problem restricts the practical application of graphene in the field of photodetectors.⁷

Hence, it is necessary to explore a new technology strategy with high light absorptivity to address this limitation. A commonly employed approach to enhance device performance is to integrate graphene with a high light absorption QDs.⁸ QDs have some exceptional properties with high light absorption coefficient, a wide range of adjustable bandgap, and a narrow linewidth in emission.^{9–11} Therefore, QDs have attracted extensive attention and applied in various fields such as

photodetectors, solar cells, and LEDs. Konstantatos *et al.* demonstrated a hybrid graphene–quantum dot phototransistor with a gain of ~10⁸ electrons per photon and a responsivity of ~10⁷ A W⁻¹.^{12,13} Hu *et al.* reported a graphene/InAs QDs/GaAs photodetector that has a responsivity of about 17.0 mA W⁻¹ and detectivity of 2.3 × 10¹⁰ Jones.¹⁴ Zheng *et al.* revealed that the photoconductive gain and detectivity of graphene-perovskite quantum dot photodetector arrive at 3.7 × 10⁴ and 6 × 10⁷ Jones.¹⁵

Besides, the zero-band gap of graphene leads to the ultra-fast carrier recombination speed and ultra-short carrier lifetime.¹⁶ The graphene photodetectors do not satisfy the requirements of high-response optoelectronic devices due to the large dark current.¹⁷ Hence, two-dimensional transition metal dichalcogenide (2D TMDC) semiconductors exhibit appealing properties, such as tunable bandgaps, high electron mobility, flexibility, and the absence of dangling bonds on their surfaces.^{18–23} These characteristics enable 2D TMDCs to be an excellent candidate for the high-performance photodetector.^{24–26} In recent years, numerous 0D/2D heterostructures with outstanding properties have been explored and reported. For instance, Zhang *et al.* explored that the detectivity of MoS₂/ZnCdSe heterostructure is reached to be 1.0 × 10¹² Jones.²⁷ Hu *et al.* reported that the responsivity and detectivity of WSe₂/PbS-QDs heterostructure are 2 × 10⁵ A W⁻¹ and 10¹³ Jones, respectively.²⁸ Mukherjee *et al.* found that the detectivity of MoS₂/PbS-QDs heterostructure reaches up to 10¹² Jones.²⁹ Among these, PbS-QDs,³⁰ HgTe-QDs,³¹ and CdS-QDs³² are

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commonly employed in the development of high-performance photodetectors. However, these devices face a challenge due to the presence of high-toxicity elements which limit their practical application.⁴ Hence, it is essential to explore alternative eco-friendly QDs possessing comparable characteristics in the photodetectors. So, low-toxicity QDs with a wide emission spectrum, tunable bandgap energy ranging from visible to near-infrared, and large Stokes shifts have emerged as promising alternatives to cadmium and lead-based QDs.^{33,34}

Here, we introduced a strategy to take advantages of high light absorption and eco-friendly I-III-VI QDs with the high carrier mobility characteristic of 2D materials, which can significantly enhance photoresponsivity and detectivity. The 0D/2D heterojunction integrated MoSe₂ and AIGS-QDs can effectively facilitate the separation of electron and hole pairs with charge transfer at the interface, leading to the enhancement of the photoelectric performance. The responsivity and detectivity of the hybrid MoSe₂/AIGS-QDs photodetector exhibit a high responsivity of 14.3 A W⁻¹ and a large detectivity of 6.4 × 10¹¹ Jones, which is three times higher than those of the MoSe₂ device. These results indicate that the utilization of hybrid MoSe₂/AIGS-QDs heterostructures in photodetectors holds significant promise for achieving high-performance detection capabilities.

2. Experimental section

2.1 Synthesis of the MoSe₂

MoSe₂ films were synthesized using a two-step process involving magnetron sputtering and a selenization process. First, the SiO₂/Si substrate was ultrasonicated sequentially in ethanol, acetone, and deionized water. Afterward, an open window of 20 μm × 100 μm or 50 μm × 50 μm was formed by photolithography method. Then, the 8 nm Mo film was deposited on SiO₂/Si substrate by the magnetron sputtering using a Mo target at a power of 30 W and a pressure of 2 × 10⁻³ Torr. The MoSe₂ film was fabricated by selenylation method in a thermal furnace (Fig. S1†). The SiO₂/Si substrate with Mo film was positioned in the center zone of a quartz tube. 500 mg Se powder was placed upstream of 18 cm away from the SiO₂/Si substrate. The quartz tube was then evacuated and argon gas was introduced to remove the residual oxygen in the tube and restore atmospheric pressure. During the reaction, the argon flow rate was maintained at 120 sccm. The substrate temperature was raised to 850 °C for 60 minutes and then maintained at 850 °C for 120 minutes. Additionally, hydrogen was introduced at a flow rate of 30 sccm for 3 hours. The temperature of the Se powder zone is initially set at 50 °C for the first 30 minutes, followed by a gradual increase to 400 °C over the next 30 minutes. It is then maintained at 400 °C for 120 minutes. Subsequently, the furnace was cooled naturally to room temperature.

2.2 Synthesis of the AIGS-QDs

For the synthesis of AIGS-QDs, a three-neck flask was charged with 0.2 mmol of AgNO₃, 0.4 mmol of indium acetate (In(Ac)₃), and 0.6 mmol of gallium acetylacetonate (Ga(Ac)₃). Following

this, a solution was prepared by injecting 2 ml of 1-dodecanethiol (DDT), 2 ml of oleylamine (OAm), and 5 ml of 1-octadecene (1-ODE) into the mixture while applying magnetic stirring. The solution was subjected to two rounds of vacuuming and nitrogen charging, followed by heating at a temperature of 50 °C for a duration of thirty minutes. Additionally, the solution was subjected to heating at a temperature of 90 °C. Subsequently, the S precursor (consisting of 1.6 mmol of sulphur dissolved in 2.5 ml of 1-ODE) was introduced into the solution. Pure AgInGaS cores can be obtained by iteratively performing precipitation and dispersion using hexane and ethanol. AIGS cores were collected to facilitate subsequent device fabrication.³⁵

2.3 Device fabrication

Electrode pattern was prepared by standard electron beam lithography (EBL) and the 3 nm Cr and 60 nm Au were deposited as electrical contacts on MoSe₂ layer by electron-beam evaporation (EBE). After that, prepared AIGS-QDs were spin-coated MoSe₂ layer with 2500 rpm for 30 s to obtain a heterojunction device.

2.4 Characterization

The crystal structure and morphology of the AIGS-QDs and MoSe₂ were measured by an X-ray diffractometer (Bruker Advanced D8), atomic force microscopy (AFM) (Bruker Multi-mode 8), an optical microscope (OM) (Olympus BX51) and transmission electronic microscopy (FEI, TECNAIG2 20 LaB6). The composition and binding energy of AIGS-QDs and MoSe₂ were determined using X-ray photoelectron spectroscopy (XPS) with the PHI QUANTERA II instrument. The optical spectra were obtained by UV-vis-IR (Shimadzu, UV3600), PL and Raman spectroscopy (Horiba, HR EVO NANO) and time-resolved PL decay transients (Horiba FLTCSPC). UPS was measured using He I lines (Thermo ESCALAB 250XI). All optoelectronic characterizations were performed using Semiconductor Device Analyzer (Keysight B1500A) at room temperature and ambient conditions. The examination of the photoelectric response properties was conducted using semiconductor lasers (MDL-III442/100 mW) with a wavelength of 442 nm. The light intensity was detected with an optical power meter (Newport PMKIT-21-01).

3. Results and discussion

The crystal structure of the MoSe₂/AIGS-QDs heterojunctions is presented in Fig. 1a. The AIGS-QDs solution illuminated under UV radiation (365 nm) appears orange. In order to confirm the crystal structure of AIGS-QDs, the XRD pattern for AIGS-QDs (Ag:Ga = 2:3) is presented in Fig. S2.† The diffraction peaks of AIGS-QDs located at 27.5°, 46.8°, and 54.7°, corresponding to the (112), (105), and (303) crystal plane of tetragonal AgInS₂ (PDF# 25-1328) and AgGaS₂ (PDF# 73-1233). The obtained results demonstrate the successful preparation of the AIGS-QDs.^{36,37} To evaluate AIGS-QDs quality, the transmission electron microscope (TEM) and high-resolution transmission



electron microscope (HRTEM) was utilized to analyze the microstructure and atomic arrangement, as shown in Fig. S3† and 1b. The TEM image and the histograms of the AIGS-QDs size distribution indicate homogeneous dispersing and the mean diameter of sphere-shaped AIGS-QDs is 2.43 nm. The particle size is mainly distributed between 2.1 and 2.7 with a narrow size distribution (Fig. S3b†). The HRTEM image exhibits continuous lattice fringes. This means that the AIGS-QDs have clear crystal structures and the interplanar spacing is 0.32 nm, which is consistent with the (112) lattice plane of AIGS-QDs.³⁸

X-ray photoemission spectroscopy (XPS) is employed to identify the elemental composition and electron binding energy in AIGS-QDs. The XPS analysis of AIGS-QDs is presented in Fig. S4,† which reveals the presence of four major elements. There are two peaks observed at 371 eV and 365 eV, which can be attributed to the Ag 3d_{3/2} and Ag 3d_{5/2} orbitals, respectively. The 3d spectra of indium (In) exhibit two prominent peaks located at 449.5 eV and 441.9 eV, which align with the

distinctive In 3d_{3/2} and In 3d_{5/2} orbitals, respectively. The peaks observed at 1141.8 eV and 1114.8 eV correspond to the Ga 2p_{1/2} and Ga 2p_{3/2} orbitals, respectively. In addition, the S 2p_{1/2} and S 2p_{3/2} orbitals exhibit energies of approximately 160 eV and 158.7 eV, respectively. All of these results are in accord with the previous reports of AIGS-QDs.^{34,39}

The MoSe₂ was grown by the selenylation method using Se power precursors and Mo film. To confirm the MoSe₂ thin film quality, Atomic Force Microscope (AFM), XPS and Raman images were gained. The thickness of MoSe₂ was verified at about 15 nm by AFM (Fig. 1c), which shows smooth surfaces of the samples and is similar to previous report.^{40,41} The optical microscope (OM) photograph of a square MoSe₂ film displayed in Fig. S5† appears uniform color. XPS measurements were introduced to further characterize the MoSe₂ film. The elements of Mo, Se, O and C can be identified in Fig. S6.† XPS spectra of the two primary elements of Mo and Se in the MoSe₂ film are presented in Fig. 1d. The two peaks at 229.3 eV and 232.4 eV correspond to the Mo 3d_{5/2} and 3d_{3/2} orbitals. Similarly, the 3d

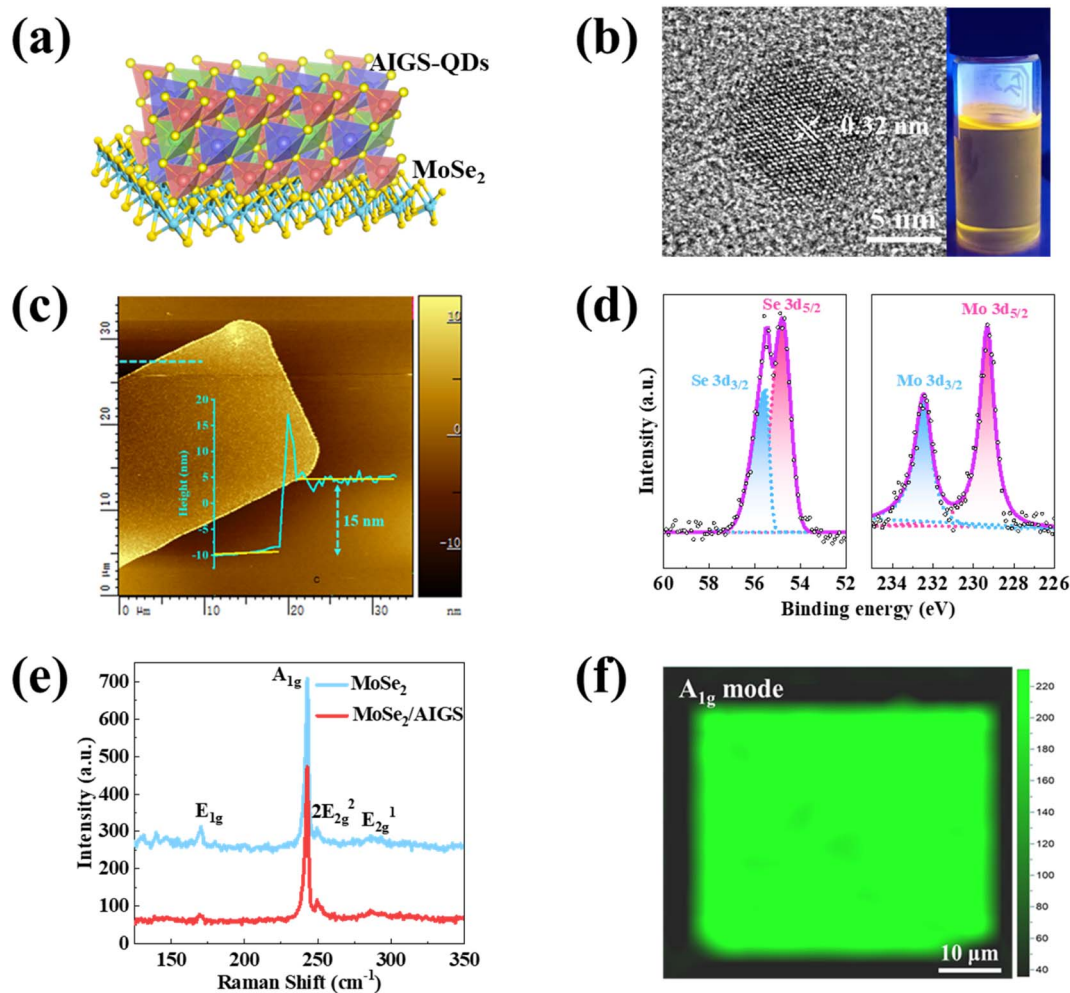


Fig. 1 Characteristics of AIGS-QDs, MoSe₂, and MoSe₂/AIGS-QDs heterojunctions. (a) Schematic representation of the crystal structure of the MoSe₂/AIGS-QDs heterojunction. (b) HRTEM image of AIGS-QDs. Inset: photograph of the AIGS-QDs solution under UV radiation (365 nm). (c) AFM image of the MoSe₂. Inset: the thickness of MoSe₂. (d) XPS of Mo and Se. (e) Raman spectra of MoSe₂ and MoSe₂/AIGS-QDs heterojunctions. (f) Raman mapping of MoSe₂ (A_{1g} mode).



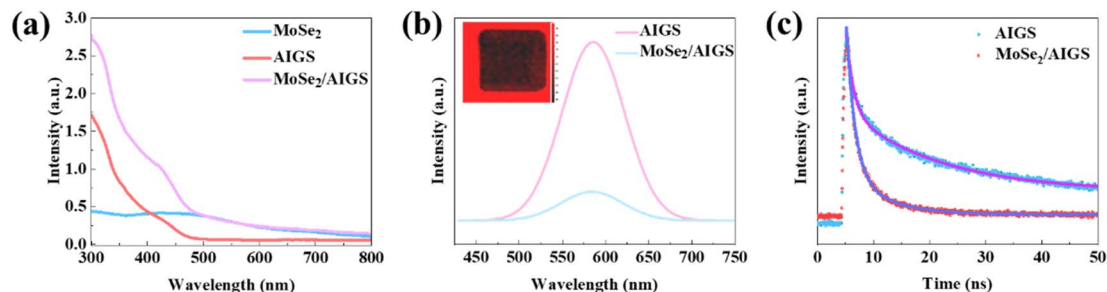


Fig. 2 Optical properties of the MoSe₂ and MoSe₂/AIGS-QDs heterojunction. (a) UV-vis absorption spectra of the MoSe₂, AIGS-QDs, and MoSe₂/AIGS-QDs. (b) PL spectra of AIGS-QDs and MoSe₂/AIGS-QDs. Inset: the PL mapping of the MoSe₂ that was covered with AIGS-QDs (the red zone is only AIGS-QDs and the dark zone is MoSe₂ coupling with AIGS-QDs). (c) TRPL decay transients measured at 570 nm for AIGS-QDs and MoSe₂/AIGS-QDs.

spectra of Se show two major peaks located at 54.8 eV and 55.5 eV, consistent with the characteristic Se 3d_{5/2} and 3d_{3/2} orbitals, respectively, which are in agreement with the previous work.^{42,43}

The Raman spectra of MoSe₂ and MoSe₂/AIGS-QDs were excited under 532 nm and presented in Fig. 1e to provide additional insights into the structure and composition of MoSe₂. The MoSe₂ sample presents a dominant Raman peak at approximately 242.0 cm⁻¹, which corresponds to an out-of-plane Raman mode known as the A_{1g} mode. Three additional peaks are observed at approximately 169.1 cm⁻¹, 249.6 cm⁻¹, and 285.7 cm⁻¹, respectively. These peaks correspond to the vibration modes of in-plane modes E_{1g}, 2E_{2g}, and E_{2g}¹, which are consistent with previous research results.^{44,45} The A_{1g} mode of MoSe₂ flake exhibits the highest intensity due to the strong interlayer interaction. Meanwhile, a higher peak intensity of the A_{1g} mode generally indicates a lower number of layers.⁴⁵ The

presence of a distinct peak in the sharp A_{1g} mode confirms the high quality of the MoSe₂ sheeting. To comprehensively understand the quality of selenylation, a Raman mapping of MoSe₂ was collected around the A_{1g} mode (242.0 cm⁻¹), as displayed in Fig. 1f. It is noteworthy to mention that the uniform intensity observed across the whole area (50 μm × 50 μm) of the MoSe₂ thin film indicates the consistent thickness. Furthermore, when the AIGS-QDs were spun on the surface of MoSe₂ (Fig. S7[†]), no new peaks were observed, suggesting that the AIGS-QDs layer does not disrupt the structure of MoSe₂.⁴⁶ Consequently, these results demonstrate the successful preparation of high-quality AIGS-QDs/MoSe₂ heterojunction, which can be used as the response materials in the photodetector.

To assess the optical properties of the MoSe₂/AIGS-QDs heterojunction, the absorption spectrum, PL, PL mapping, and TRPL were recorded. The UV-vis absorption spectra of the pure AIGS-QDs, MoSe₂, and hybrid MoSe₂/AIGS-QDs samples

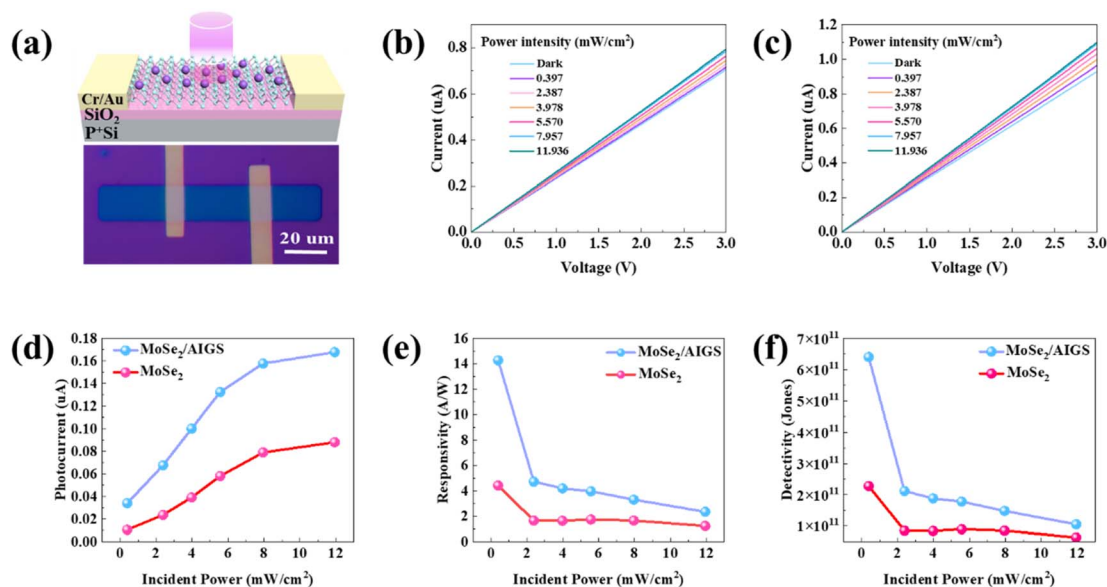


Fig. 3 Photoelectric response characteristics of the MoSe₂ and MoSe₂/AIGS-QDs heterojunction device under 442 nm illumination. (a) Schematic diagram and optical image of the hybrid photodetector. (b and c) Output current of the MoSe₂ and hybrid MoSe₂/AIGS-QDs photodetector measured under different power intensities. (d–f) Photocurrent, responsivity and specific detectivity of the MoSe₂ and hybrid MoSe₂/AIGS-QDs photodetector measured at V_{ds} = 3 V under different power intensities.

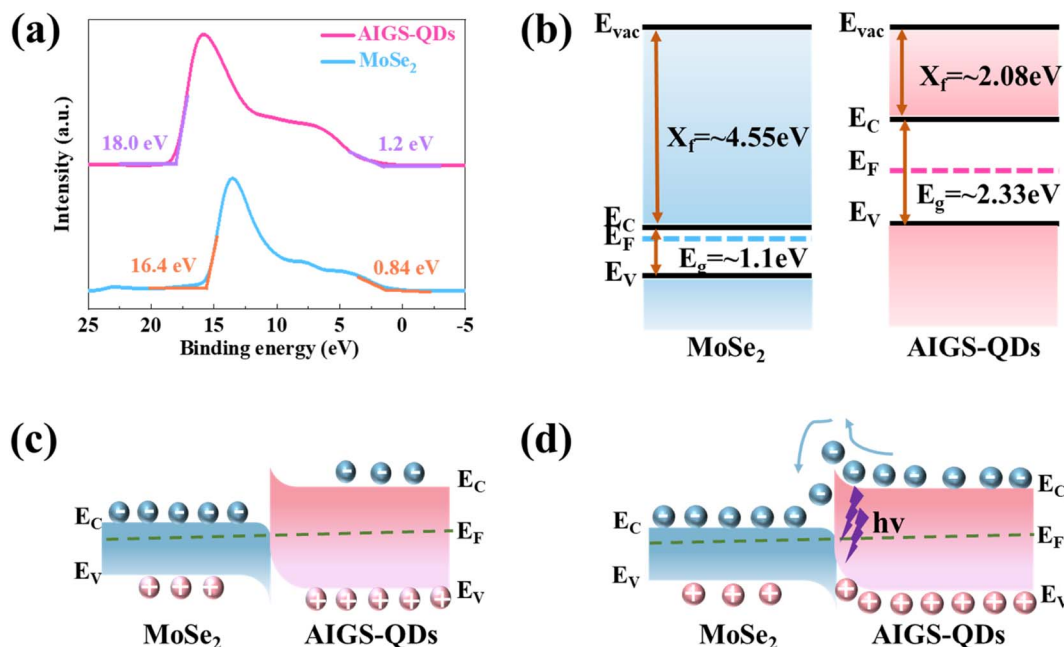


Fig. 4 Charge transfer mechanism. (a) Ultraviolet photoelectron spectroscopy (UPS) measurement results of AIGS-QDs and MoSe₂. (b) Energy band diagram of MoSe₂ (left) and AIGS-QDs (right). (c and d) Mechanism of charge-carrier injection between AIGS-QDs and MoSe₂ in contact state under dark and contact state under illumination.

were measured, as depicted in Fig. 2a. The absorption spectrum of MoSe₂ displays a broad absorption range spanning from 300 to 800 nm. When the AIGS-QDs were coated on the MoSe₂ film, the MoSe₂ film exhibited a significantly enhanced absorption in the wavelength range of 300–480 nm, which is attributed to the cooperative absorption of AIGS-QDs and the MoSe₂ layers. This high absorption of the hybrid MoSe₂/AIGS-QDs heterojunction indicates its potential for application in the field of photodetectors.^{47,48}

The PL spectra of AIGS-QDs and MoSe₂/AIGS-QDs heterostructure were obtained with photoexcitation at 3.8 eV (325 nm) and emerged in Fig. 2b. There is a peak around 577 nm in PL of pure AIGS-QDs. After being coupled with MoSe₂, there exhibits a significant quenching of about 84% reduction compared with that of the pristine AIGS-QDs. This phenomenon explains that

a large number of photon-generated carriers may be transferred between AIGS-QDs and MoSe₂.⁴⁹ The PL mapping was measured to further reveal the charge exchange between AIGS-QDs and MoSe₂. As shown in the inset of Fig. 2b, the zone of QDs was bright (red color) but the zone of MoSe₂ was dark square, which illustrates that MoSe₂ has a strong quenching of PL on AIGS-QDs. This PL quenching is associated with the charge transfer at the interface of the AIGS-QDs and MoSe₂ heterojunction.⁵⁰

To comprehensively elucidate the charge transfer dynamics occurring at the interfaces between MoSe₂ and AIGS-QDs, TRPL measurements were utilized. The TRPL decay curves in Fig. 2c were fitted using a biexponential decay equation to determine the lifetime of both AIGS-QDs and the MoSe₂/AIGS-QDs heterostructure. The pristine AIGS-QDs exhibited a significantly long PL lifetime of 15.84 ns, indicating slow recombination of

Table 1 Performance comparison of the reported 2D–0D heterojunction photodetectors

	Layer thickness	Measurement condition (nm)	R (A W ⁻¹)	D^* (Jones)	References
MoS ₂ /PbS-QDs	8 nm	400–1600	0.6	10 ¹²	29
WSe ₂ /CdSe-QD	1.019 nm (CVD)	638	9.27	4.38 × 10 ¹⁰	56
MoS ₂ /ZnO-QDs	Monolayer (CVD)	405	0.084	1.05 × 10 ¹¹	57
Graphene/WS ₂ QDs	Monolayer (CVD)	365	3.1 × 10 ²	8.9 × 10 ⁸	61
MoSe ₂ /CsPb(Cl/Br) ₃ -QDs	Few-layer	455	104	—	62
MoSe ₂	Few-layer	455	34	—	62
MoSe ₂	Monolayer	514	0.32	3.54 × 10 ¹²	63
MoSe ₂	44 nm	785	238	7.6 × 10 ¹¹	64
MoS ₂ /PbSe-QDs	4.02 nm	1310	137.6	7.7 × 10 ¹⁰	65
<i>n</i> -WS ₂ / <i>p</i> -PbS QDs	Multilayer	1550	0.18	4.11 × 10 ¹¹	66
MoSe ₂	15 nm	442	4.42	2.28 × 10 ¹¹	This work
MoSe ₂ /AIGS-QDs	15 nm	442	14.3	6.4 × 10 ¹¹	This work



carriers in the AIGS-QDs. However, when coupled with MoSe₂, the lifetime (τ) decreases significantly from 15.84 to 4.46 ns, suggesting a substantial charge transfer occurring at the interface between AIGS-QDs and MoSe₂.^{48,51} Under light illumination, photogenerated electrons exhibit a strong tendency to transfer from AIGS-QDs to MoSe₂, while the generated holes remain in AIGS-QDs, forming the separation of the electrons and holes. This charge transfer results in a reduced probability of recombination⁵¹ and the accumulation of unpaired electrons and holes, leading to strong quenching and the shortened lifetime of the PL. Meanwhile, charge transfer is beneficial to the electrons and holes separation at the interface of the heterojunction, which is advantageous for enhancing the photocurrent. The strong optical absorption and effective charge transfer demonstrate that MoSe₂/AIGS-QDs heterojunction is a promising application in photodetector.

The schematic diagram and practical optical image of the MoSe₂ and MoSe₂/AIGS-QDs photodetector device are depicted in Fig. 3a. To compare the photoelectric detection performance between MoSe₂ devices with and without AIGS-QDs, the output curves were plotted in Fig. 3b and c. Both the I - V curves of the MoSe₂ and MoSe₂/AIGS-QDs heterostructure device are linear, which implies a good ohmic contact between Cr/Au electrodes and MoSe₂ (or MoSe₂/AIGS-QDs). The dark current of the original and heterojunction devices is measured to be approximately 0.706 μ A and 0.931 μ A, respectively, at a source-drain voltage (V_{ds}) of 3 V. Under light irradiation (illuminated by a 442 nm laser at 11.936 mW cm⁻²), the output current of the MoSe₂ heterojunction device increased from 0.706 μ A to 0.795 μ A, compared with that in the dark. After being coupled with AIGS-QDs, the output current of the hybrid device increases to 1.099 μ A. The photocurrents ($I_{ph} = I_{light} - I_{dark}$) of the device were calculated in Fig. 3d. Both the photocurrents of the pure MoSe₂ device and the hybrid device exhibit a monotonic increase with increasing optical power intensity. It is worth pointing out that after combining with QDs, the photocurrent is two times larger than that of the pristine MoSe₂ photodetector. This phenomenon demonstrates that the integration of AIGS-QDs with MoSe₂ leads to an increase in photocurrent in hybrid devices. These results suggest that the photosensitizing layer AIGS-QDs can effectively improve the performance of the MoSe₂ photodetector.

To evaluate the device performance of the photocurrent in individual MoSe₂ and heterojunction photodetector, two important indicators, namely responsivity (R) and specific detectivity (D^*), are introduced. These indicators play a crucial role in determining the performance of photodetectors.

The photoelectric conversion capability of the device, denoted as R , was evaluated with a wavelength of 442 nm under various incident power intensities at 3 V. The responsivity was calculated using the formula $R = I_{ph}/PS$,⁵²⁻⁵⁴ where I_{ph} represents the photocurrent, P denotes the incident power intensity, and S represents the area of the device channel with dimensions of 30 μ m length and 20 μ m width. As shown in Fig. 3e, there is a decrease in the responsivity of both devices as the incident power intensity increases. This trend may be attributed to the lower recombination probability of carriers at lower incident power intensity.⁵⁵ The highest responsivity was found at the

minimum incident power intensity (0.357 mW cm⁻²) for the MoSe₂ device is about 4.42 A W⁻¹. Once the AIGS-QDs were coated on the MoSe₂ surface, the responsivity was calculated to be 14.3 A W⁻¹, which is improved more than three times compared to that of the MoSe₂ photodetector. This value is at a higher level compared with those in previous work, such as MoS₂/PbS-QDs (0.6 A W⁻¹),²⁹ WSe₂/CdSe-QD (9.27 A W⁻¹),⁵⁶ and MoS₂/ZnO-QDs (0.084 A W⁻¹).⁵⁷ These results demonstrate our hybrid 2D/QDs device presents a potential replacement for toxic hybrid photodetectors with excellent performance.

In addition, the D^* is another crucial parameter for assessing the capability of signal detection in the presence of noise. It is defined as $D^* = RS^{1/2}/(2eI_{dark})^{1/2}$, where S represents the effective detection area of the device, e denotes the electronic charge, and I_{dark} corresponds to the dark current, as illustrated in Fig. 3f.^{58,59} Similar to R , the maximum value of D^* for the device is observed at the minimum light power. After being deposited with the AIGS-QDs layer, the D^* value of the heterojunction device increases three times compared to that of the MoSe₂ device (from 2.28×10^{11} Jones to 6.4×10^{11} Jones). Furthermore, the D^* value of the MoSe₂/AIGS-QDs device is superior to those of previously reported 2D/0D photodetectors. For instance, the D^* value of WSe₂/CdSe-QD was reported to be 4.38×10^{10} Jones,⁵⁶ MoS₂/PbS-QDs had a D^* value of 1×10^{11} Jones,⁶⁰ and graphene/WS₂-QDs exhibited a D^* value of 8.9×10^8 Jones.⁶¹ These results indicate that the MoSe₂/AIGS-QDs photodetector shows promising application prospects in detecting low light intensity.

To gain a deeper comprehension of the charge transfer mechanism, ultraviolet photo-electron spectroscopy (UPS) was employed to elucidate the energy band structures of the AIGS-QDs and MoSe₂, as depicted in Fig. 4a and b. The work function (W_F) refers to the energy of the highest occupied states and can be determined using the equation $W_F = h\nu - E_{onset}$,^{67,68} where $h\nu = 21.21$ eV represents the energy of the incident photon and E_{onset} corresponds to the onset level associated with the secondary electrons. According to the UPS results, the work function (W_F) values of AIGS-QDs and MoSe₂ were estimated to be 3.21 eV and 4.81 eV, respectively. Subsequently, the energy of the valence band maximum (E_{VBM}) of AIGS-QDs and MoSe₂ is calculated to be 1.2 eV and 0.84 eV, respectively. Furthermore, the energy values for the conduction band minimum (E_{CBM}) are determined to be 2.08 eV and 4.55 eV, based on the fitting of the optical bandgaps with the absorption spectrum (Fig. S8†). In conclusion, the energy band alignment diagrams of AIGS-QDs and MoSe₂ (Fig. 4b) indicate that the MoSe₂/AIGS-QDs heterojunction forms a type II band alignment heterojunction.⁵¹

The increased responsivity and detectivity observed in the MoSe₂/AIGS heterojunction photodetector, as compared to the MoSe₂ device, are attributed to the type II energy band alignment. When the AIGS-QDs come into contact with MoSe₂ (Fig. 4c) and form a heterojunction, the difference in Fermi levels causes electrons and holes at the interface to diffuse and drift, aligning the Fermi level and establishing a new equilibrium. This results in the bending of the energy band and the formation of a depletion region, creating a built-in field.^{57,69} Under illumination (Fig. 4d), AIGS-QDs absorb photon energy and generate electron-hole pairs. Subsequently, these pairs are efficiently separated by the inherent electric field at the



interface of the heterojunction. As a consequence, the transfer of electrons occurs towards the MoSe₂ side, while holes remain on the AIGS-QDs side. As a consequence, the transfer of electron–hole pairs from AIGS-QDs to MoSe₂ leads to a substantial improvement in responsivity and detectivity.^{67,68}

To comprehensively evaluate the photoelectric performances of the MoSe₂/AIGS-QDs device, we have compared our work with similar studies and summarized the results in Table 1. The MoSe₂/AIGS-QDs device demonstrates outstanding responsivity and detectivity, highlighting its exceptional photo-response properties.

4. Conclusions

In summary, the sensitizing layer AIGS-QDs were successfully integrated into the MoSe₂ surface to form a high-performance photodetector. The difference in the Fermi level enables the transfer of charges from AIGS-QDs to MoSe₂, resulting in a strong quenching of the PL of AIGS-QDs and a shortening in the decay time of PL in the MoSe₂/AIGS-QDs heterojunction. The photodetector with MoSe₂/AIGS-QDs heterojunction demonstrates exceptional performance attributed to its efficient charge transfer at the interface. It exhibits a responsivity of 14.3 A W⁻¹ and a specific detectivity of 6.4 × 10¹¹ Jones. The responsivity and detectivity of the hybrid phototransistor are significantly enhanced by more than three times compared with that of the MoSe₂ photodetector. The results present that the incorporation of AIGS-QDs sensitizing layer into MoSe₂ can significantly enhance the optoelectronic performance of MoSe₂ devices, making it a promising candidate for high-performance photodetector applications.

Author contributions

XJZ and XSW contribute equally to this work. XJZ, XSW, RMJ and YHL grow the samples and fabricate the devices. XJZ, XSW, and RMJ conduct AFM, Raman, absorption spectrum and PL measurement. XJZ and YHL conduct Raman mapping and PL mapping measurement. TTG, XDH, LXW, and TZ, DNY help picture the device diagram and analysis of the XRD data. XJZ and XSW initiate the project and write the manuscript. XFS and XC provide grammar and word modification suggestions for the manuscript. XFS and XC provide suggestions and funding for the research. All authors discussed the results and approved the final version of the manuscript.

Conflicts of interest

The authors declare no conflicts of interest.

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